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Abe

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(54) **LASER TREATMENT APPARATUS**

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(58) **Field of Classification Search** 351/205, 351/207, 211, 218, 220, 221; 606/4–13, 606/16–1; 600/101, 104, 108
See application file for complete search history.

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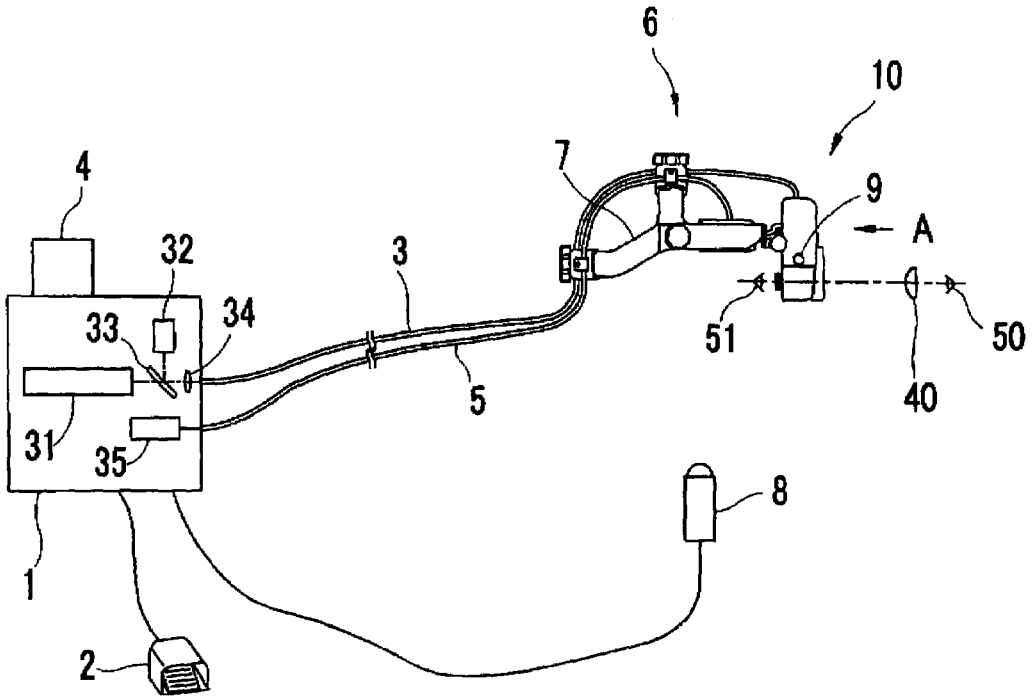
(57) **ABSTRACT**

A laser treatment apparatus comprises: a binocular indirect ophthalmoscope which is fixedly mounted on a head of an operator during use; an irradiation optical system which is placed in the ophthalmoscope and adapted to irradiate a treatment laser beam delivered into the ophthalmoscope to a treatment part of a patient; and a shift unit which is placed in the irradiation optical system and adapted to shift an irradiation position of the treatment beam in two-dimensional, vertical and horizontal directions.

3 Claims, 4 Drawing Sheets